



LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		ATTY DOCKET NO.: S63.2B-11022- US01		APPLICATION NO.: 10/824996		
		APPLICANT: Weber, Holman				
		FILING DATE: April 14, 2004		GROUP: 3763		
REFERENCE DESIGNATION		U.S. PATENT AND PUBLISHED APPLICATION DOCUMENTS				
EXAM'S INIT.		DOCUMENT NUMBER	DATE	NAME	CLASS/ SUBCLASS	FILING DATE IF APPROPRIATE
Cfr	AA	20020052641	5/2/02	Monroe et al	623/1.11	
	AB	4921483	5/1/90	Wijay et al	604/96	
	AC	5250059	10/5/93	Andreas et al	606/159	
	AD	5300032	4/5/94	Hibbs et al	604/64.1	
	AE	5425712	6/20/95	Goodin	604/96	
	AF	5769830	6/23/98	Parker	604/282	
	AG	5993415	11/30/99	O'Neil et al	604/96	
	AH	6113579	9/5/00	Eidenschink et al	604/264	
	AI	6245053	6/12/01	Benjamin	604/523	
	AJ	6325790	12/4/01	Trotta	604/523	
Cfr	AK	6355027	3/12/02	Le et al	604/525	
FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY		
Cfr	BA	03/013638		WO		
OTHER ART (Including Author, Title, Date, Pertinent Pages, Ect.)						
Cfr	CA	Afanasiev, Y.V., et al, <i>Hydrodynamic regimes of UV laser ablation of polymers</i> , Applied Physics, vol.A64, no.6 p.561-72 (June 1997).				
Cfr	CB	Minamitani, Y. & Sasagawa, T., <i>Excimer laser processing system using holographic optical elements</i> , Mitsubishi Electric Advance, vol.81 p.27-8 (Dec. 1997).				
Cfr	CC	Meijer, J., et al, <i>Laser machining by short and ultrashort pulses, state of the art and new opportunities in the age of the photons</i> , CIRP Annals - Manufacturing Technology, v 51 n p 531-550 (2002).				
EXAMINER Cfr			DATE CONSIDERED 2/18/05			
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.						



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Ch	AA	6368301	4/9/02	Hamilton et al	604/103	
I	AB	6403011	6/11/02	Stamberg	264/400	
I	AC	6514228	2/4/03	Hamilton et al	604/96.01	
Ch	AD	6517515	2/11/03	Eidenschink	604/101.05	
	AE					
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	BA					
	BB					
	BC					
OTHER ART (Including Author, Title, Date, Pertinent Pages, Ect.)						
Ch	CA		Golub, Michael & Grossinger, Israel , <i>Diffraction optical elements for biomedical applications</i> , Proceedings of SPIE - The International Society for Optical Engineering, v 3199 p 220-23 (1997).			
Ch	CB		Andrew, J.E., et al, <i>Direct etching of polymeric materials using a XeCl laser</i> , Applied Physics Letters vol.43, no.8 p.717-19 (15 Oct. 1983).			
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Ch	AA	6746424	6/8/04	Stamberg	604/103.06		
	AB						
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